

TSMC-00-166



October 29, 2003

2826/1

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Ave
Poughkeepsie, NY 12603

RECEIVED
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TECHNOLOGY CENTER 2800

Subject: | Serial No. 09/679,514 10/06/00 |
| Hung-Jen Hsu |

"A METHOD TO IMPROVE PASSIVATION
OPENINGS BY REFLOW OF PHOTORESIST
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated August 8, 2003,
please amend the above-identified application for patent as
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents
P.O. Box 1450, Alexandria, VA 22313-1450, on November 10,
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature [Signature]
Date 11/10/03